

# ***Compact modeling of junctionless nanowire MOSFETs***

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# Outline

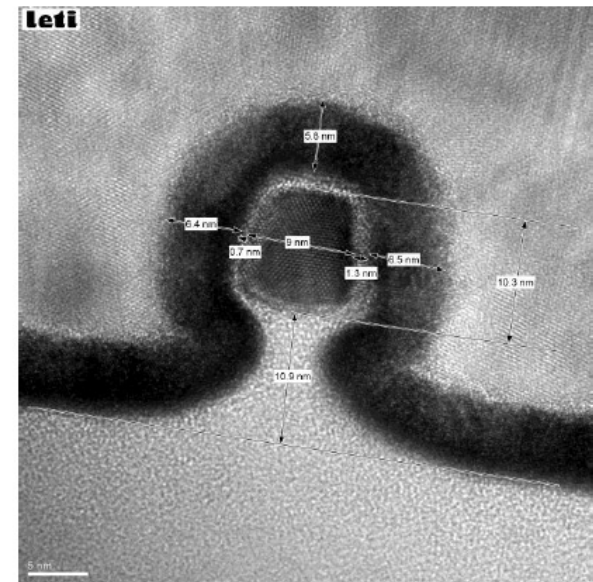
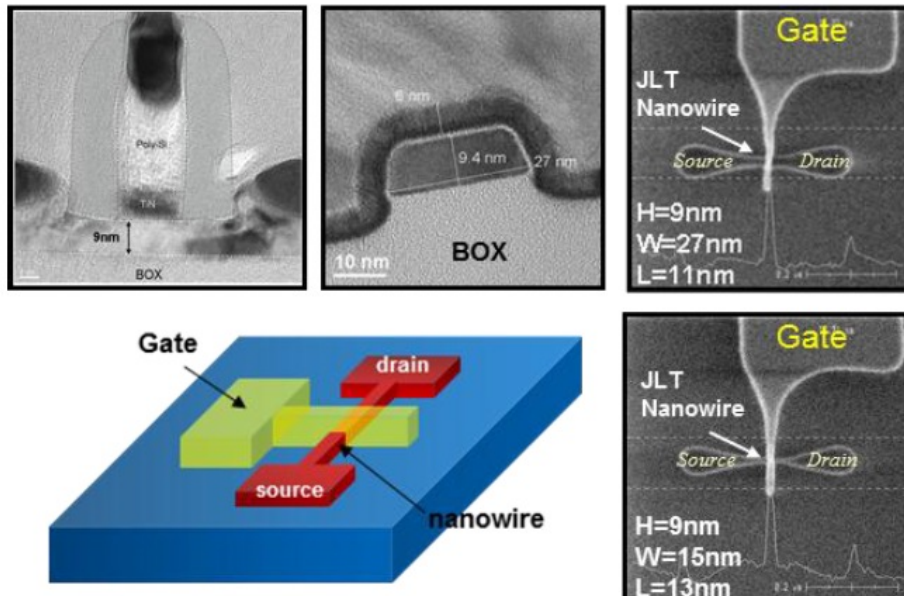
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- Introduction
- Drain current and charge models in depletion
- Drain current and charge models in accumulation
- Unified drain current model
- Capacitance model
- Results
- Conclusion

# Importance of the Junctionless Transistors

- Do not need source and drain junctions[1,2]
  - EASY to down-scale
  - EASY to fabricate

LETI's JLT Nanowire (FinFET)



[1] J.P. Colinge, C.W. Lee, A. Afzalian, N.D. Akhavan, R. Yan, I. Ferain *et al.* Nanowire transistors without junctions *Nat Nanotechnol*, 5 (2010), pp. 225–229  
 [2] C.W. Lee, A. Afzalian, N.D. Akhavan, R. Yan, I. Ferain, J.P. Colinge *Microelectron J*, 40 (2009), p. 053511

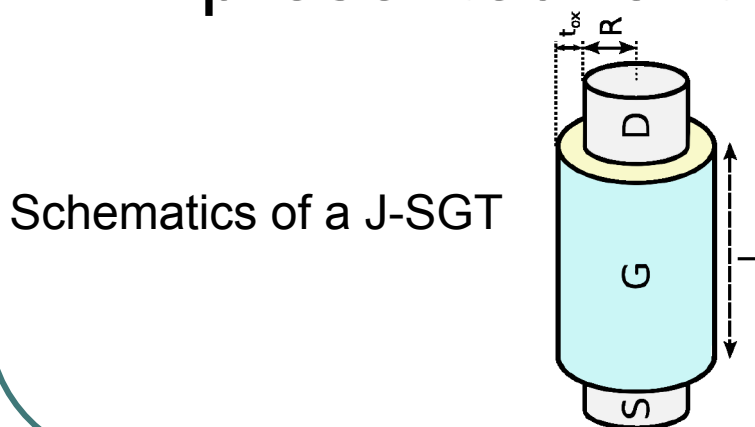
# Junctionless Transistors

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- Implementation in integrated circuits is **NECESSARY**
  - NEED of compact models adequate for circuit simulators
    - better computation speed
- Circuit design requires a complete small-signal model
  - analytical expressions of total capacitances

# Junctionless SGT

- Allows excellent control of the channel charge in the Si film
- Total charges and analytical intrinsic capacitance expressions for J-SGT are presented for the first time



← Simulation of a J-SGT

# Electrostatic analysis

$$\frac{\partial^2 \psi}{\partial r^2} + \frac{1}{r} \frac{\partial \psi}{\partial r} = \frac{qN_d}{\epsilon_{sc}} \left( e^{\frac{\psi(r)-V}{\phi_t}} - 1 \right) \quad u = r^2$$

$$\begin{aligned} u \left( \frac{\partial \psi}{\partial u} \right)^2 \Big|_0^{R^2} + \int_0^{R^2} \left( \frac{\partial \psi}{\partial u} \right)^2 du \\ = \frac{qN_d \phi_t}{2\epsilon_{sc}} \left( e^{\frac{\psi_s - V}{\phi_t}} \left( 1 - e^{\frac{\psi_0 - \psi_s}{\phi_t}} \right) - \frac{\psi_s - \psi_0}{\phi_t} \right) \end{aligned}$$

Parabolic potential approximation  $\psi(r) = \frac{\psi_s - \psi_0}{R^2} r^2 + \psi_0$

This leads to:

$$v = \ln \left( \frac{Q_m}{Q_{dop}} \right) + \frac{Q_m}{C_{ox} \phi_t} - \ln \left( \frac{Q_{cp} \left[ 1 - e^{-\frac{Q_m - Q_{dop}}{Q_{cp}}} \right]}{Q_m - Q_{dop}} \right)$$

$$Q_{cp} = \frac{2\epsilon_{sc} \phi}{R} \quad v = \frac{V_g^* + \frac{Q_{dop}}{C_{ox}} - V}{\phi_t}$$

# Drain Current and Charge Models

- Depletion mode

$$\frac{V_g^* + \frac{Q_{dop}}{C_{ox}} - V}{\phi_t} + \frac{Q_{dop}}{Q_{cp}} = \ln\left(\frac{Q_m}{Q_{cp}}\right) + \frac{Q_m}{Q_{eq}}$$

$$Q_{cp} = \frac{2\epsilon_{sc}\phi_t}{R} \quad Q_{dop} = qN_d \frac{R}{2}$$

$$Q_{eq} = \frac{Q_{cp}C_{ox}\phi_t}{Q_{cp} + C_{ox}\phi_t}$$

$$dV = -\phi_t \left( \frac{1}{Q_m} + \frac{1}{Q_{eq}} \right) dQ_m$$

$$I_{dsdep} = \frac{2\pi R\mu}{L} \int_0^{V_{DS}} Q_m dV$$

$$I_{dsdep} = -\frac{2\pi R\mu}{L} \phi_t \int_{Q_s}^{Q_d} Q_m \left( \frac{1}{Q_m} + \frac{1}{Q_{eq}} \right) dQ_m = \frac{2\pi R\mu}{L} \phi_t \left( Q_m + \frac{Q_m^2}{2Q_{eq}} \right) \Big|_{Q_s}^{Q_d}$$

$$Q_m \approx Q_{eq} LW \left( \frac{Q_{cp}}{Q_{eq}} e^{v + \frac{Q_{dop}}{Q_{cp}}} \right)$$

# Drain Current and Charge Models

- Depletion mode

$$Q_{totdep} = -2\pi R \int_0^L Q_m dx = -(2\pi R)^2 \frac{\mu}{I_{dsdep}} \int_0^{V_{DS}} Q_m^2 dV$$

$$Q_{cp} = \frac{2\epsilon_{sc}\phi}{R} \quad Q_{dop} = qN_d \frac{R}{2}$$

$$Q_{eq} = \frac{Q_{cp} C_{ox} \phi}{Q_{cp} + C_{ox} \phi}$$

$$Q_{totdep} = (2\pi R)^2 \frac{\mu}{I_{dsdep}} \phi \left( \frac{Q_m^2}{2} + \frac{Q_m^3}{3Q_{eq}} \right) \Big|_{Q_s}^{Q_d}$$

$$Q_m \approx Q_{eq} LW \left( \frac{Q_{cp}}{Q_{eq}} e^{v + \frac{Q_{dop}}{Q_{cp}}} \right)$$

$$Q_{Ddep} = -2\pi R \int_0^L Q_m dx = \frac{-(2\pi R)^3 \mu^2 \phi^2}{L I_{dsdep}^2} \int_{Q_s}^{Q_d} Q_m^2 \left( Q_m - Q_s + \frac{Q_m^2 - Q_s^2}{2Q_{eq}} \right) \cdot \left( \frac{1}{Q_m} + \frac{1}{Q_{eq}} \right) dQ_m$$

$$Q_{Sdep} = Q_{totdep} - Q_{Ddep}$$



# Drain Current and Charge Models

- Accumulation Mode

$$\frac{V_g^* + \frac{Q_{dop}}{C_{ox}} - V}{\phi_t} = \ln\left(\frac{Q_m^2}{Q_{dop}Q_{cp}}\right) + \frac{Q_m}{C_{ox}\phi_t}$$

$$dV = -\phi_t \left( \frac{2}{Q_m} + \frac{1}{C_{ox}\phi_t} \right) dQ_m$$

$$I_{dsacc} = -\frac{2\pi R\mu}{L} \phi_t \left( 2Q_m + \frac{Q_m^2}{2C_{ox}\phi_t} \right) \Big|_{Q_s}^{Q_d}$$

$$Q_m \approx 2C_{ox}\phi_t LW \left( \frac{\sqrt{Q_{cp}Q_{dop}}}{2C_{ox}\phi_t} e^{\frac{v}{2}} \right)$$

# Drain Current and Charge Models

- Accumulation Mode

$$Q_{totacc} = (2\pi R)^2 \frac{\mu}{I_{dsacc}} \phi t \left( Q_m^2 + \frac{Q_m^3}{3C_{ox}\phi t} \right) \Big|_{Q_s}^{Q_d}$$

$$Q_{Dacc} = -2\pi R \int_0^L \frac{x}{L} Q_m dx = \frac{-(2\pi R)^3 \mu^2 \phi t^2}{LI_{dsacc}^2}$$

$$\int_{Q_s}^{Q_d} Q_m^2 \left( 2(Q_m - Q_s) + \frac{Q_m^2 - Q_s^2}{2C_{ox}\phi t} \right) \cdot \left( \frac{2}{Q_m} + \frac{1}{C_{ox}\phi t} \right) dQ_m$$

$$Q_m \approx 2C_{ox}\phi_t LW \left( \frac{\sqrt{Q_{cp}Q_{dop}}}{2C_{ox}\phi_t} e^{\frac{v}{2}} \right)$$

$$Q_{Sacc} = Q_{totacc} - Q_{Dacc}$$

# Unified Drain Current Model

- An approximate solution of:

$$v = \ln\left(\frac{Q_m}{Q_{dop}}\right) + \frac{Q_m}{C_{ox}\phi_t} - \ln\left(\frac{Q_{cp}\left[1 - e^{-\frac{Q_m - Q_{dop}}{Q_{cp}}}\right]}{Q_m - Q_{dop}}\right)$$

$$Q_m = C_{ox}\phi_t LW \left( \frac{Q_{dop}Q_{cp}}{C_{ox}\phi_t} \frac{1 - e^{-\frac{Q_{dop} - Q_m^a}{Q_{cp}}}}{Q_m^a - Q_{dop}} e^v \right)$$

$$Q_{eq} = \frac{Q_{cp}C_{ox}\phi_t}{Q_{cp} + C_{ox}\phi_t}$$

$$Q_m^a = Q_{eq} LW \left( \frac{Q_{dop}Q_{cp}}{Q_{eq}} \frac{e^{\frac{Q_m^a}{Q_{cp}}} - e^{-\frac{Q_{dop}}{Q_{cp}}}}{Q_m^a - Q_{dop}} e^v \right)$$

$$v = \frac{V_{gs} - V_{FB} + \frac{Q_{dop}}{C_{ox}} - V}{\phi_t}$$

# Unified Drain Current Model

$$I_{ds} = 2\pi \frac{R}{L} \mu \phi_t (f(Q_m(0)) - f(Q_m(V_{ds})))$$
$$f(Q) = \frac{Q^2}{2Q_{eq}} + 2Q - A Q \ln \left( 1 + e^{\frac{Q - Q_{dop}}{2AQ_{cp}}} \right)$$
$$+ Q_{dop} \ln \left( \frac{Q - Q_{dop}}{2Q_{cp} \left( e^{\frac{Q - Q_{dop}}{2Q_{cp}}} - 1 \right)} \right)$$

With  $A=1,425$

# Intrinsic Capacitance Model

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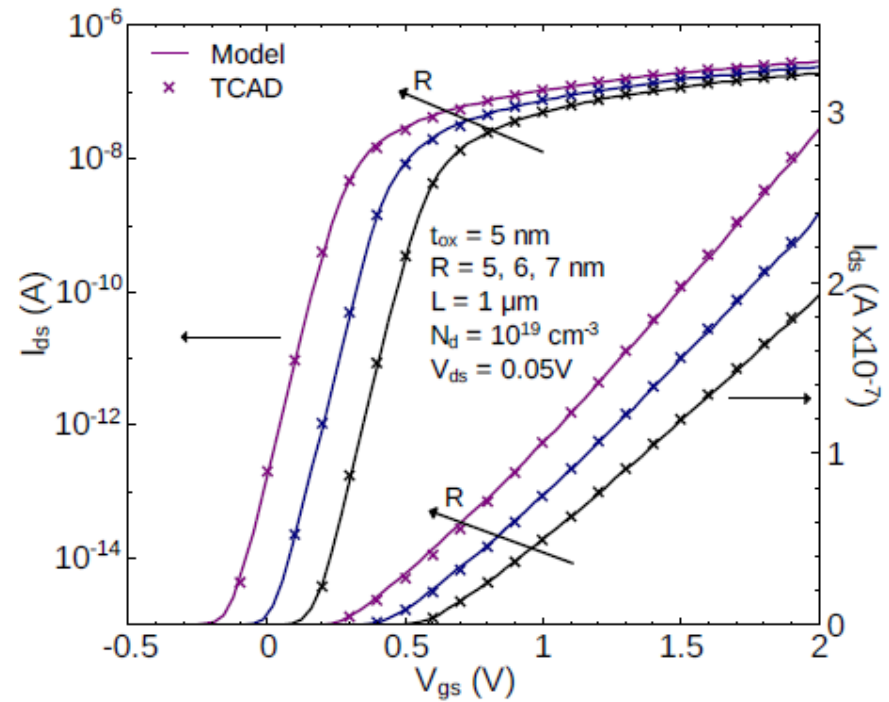
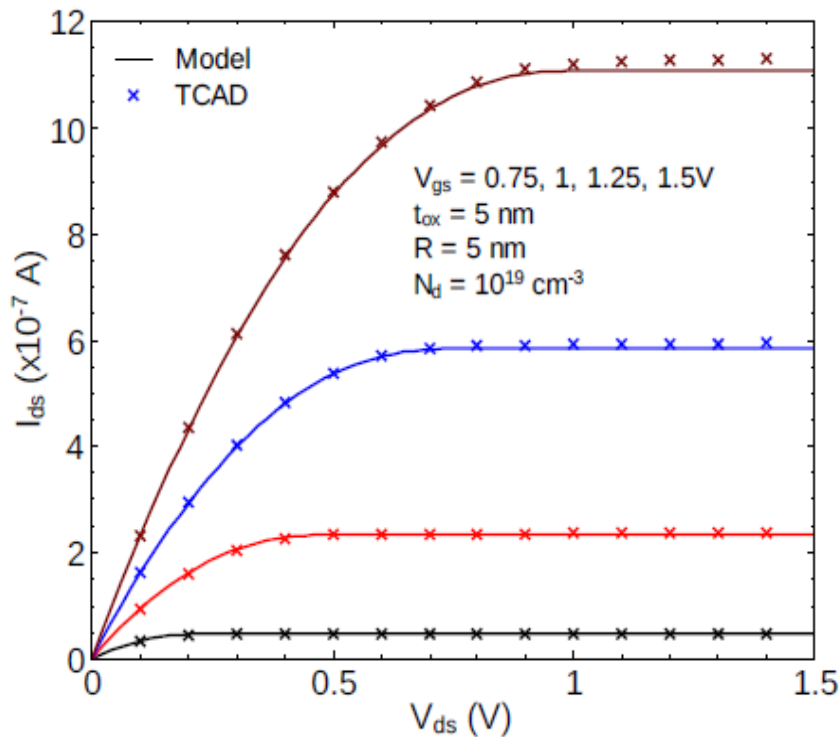
$$C_{ijdep/acc} = -\frac{\partial Q_{idep/acc}}{\partial V_j} = -\frac{\partial Q_{idep/acc}}{\partial Q_j} \cdot \frac{\partial Q_j}{\partial V_j} \quad i \neq j$$

$$C_{ijdep/acc} = \frac{\partial Q_{idep/acc}}{\partial V_j} = \frac{\partial Q_{idep/acc}}{\partial Q_j} \cdot \frac{\partial Q_j}{\partial V_j} \quad i = j$$

- The complete capacitance model = sum of capacitances in depletion and accumulation modes sewed together by a *tanh* function

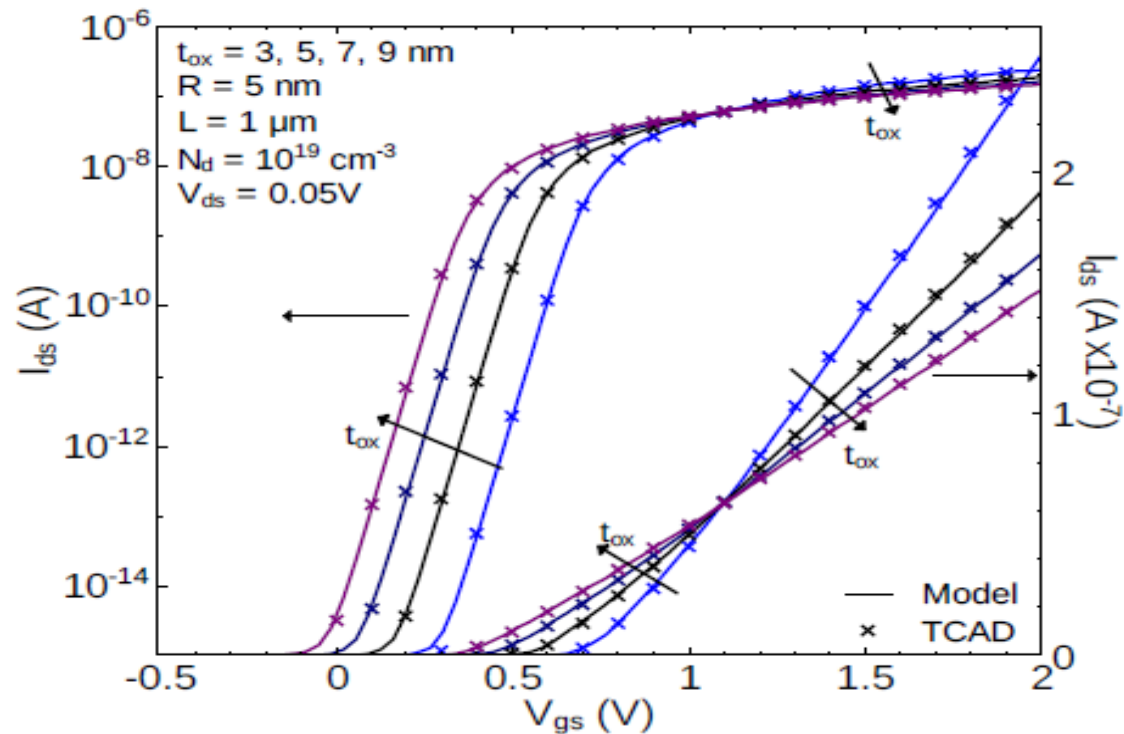
$$C_{ij} = C_{ijdep} \left( \frac{1 - \tanh\left[\left(V_g^* + q1\right)q2\right]}{2} \right) + C_{ijacc} \left( \frac{1 + \tanh\left[\left(V_g^* + q1\right)q2\right]}{2} \right)$$

# ATLAS simulations vs MODEL



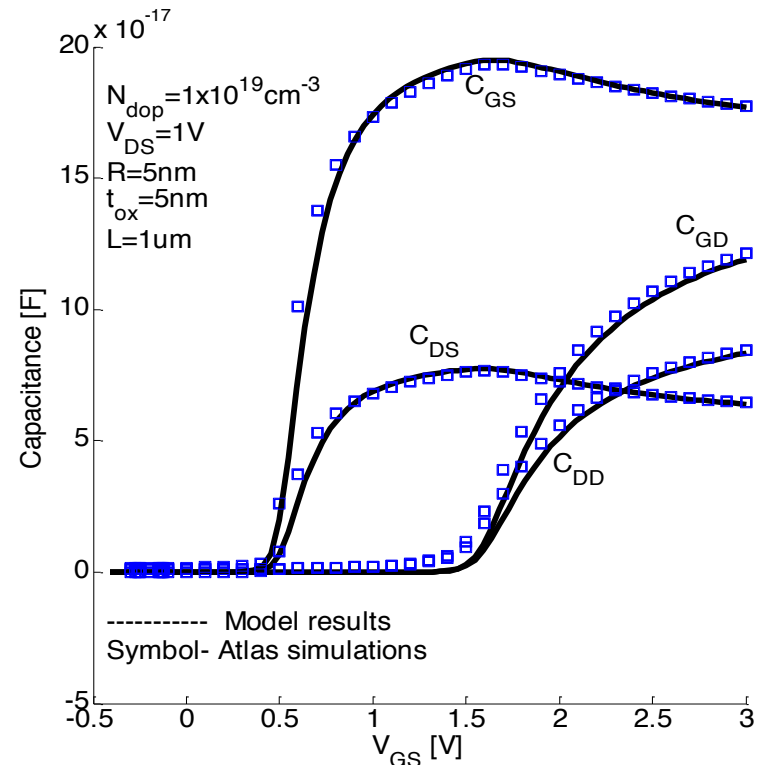
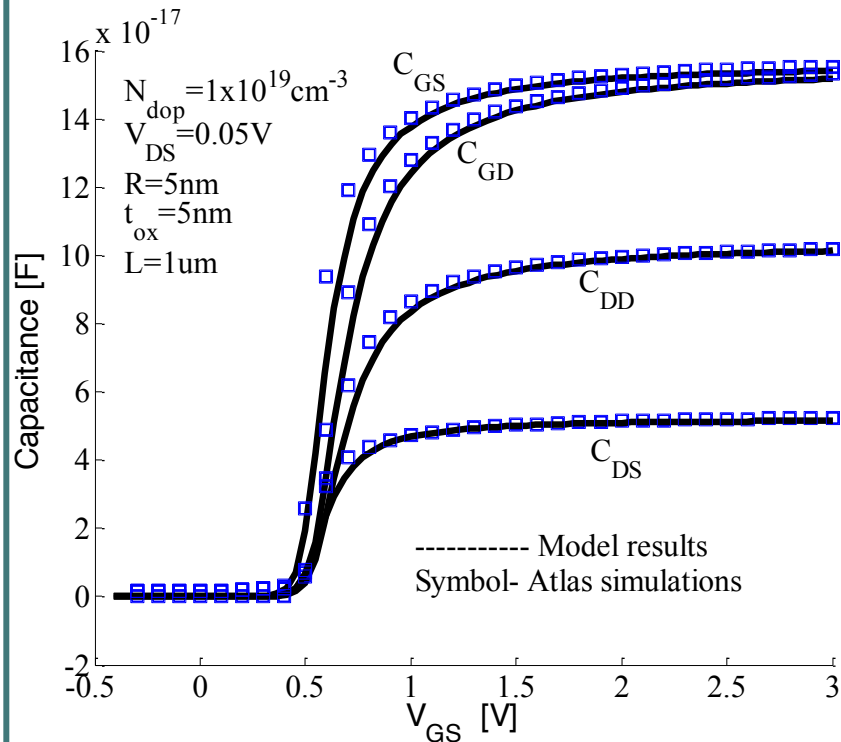
Comparison of the modeled I-V characteristics with TCAD simulations

# ATLAS simulations vs MODEL



Comparison of the modeled I-V characteristics with TCAD simulations for different values of the gate oxide

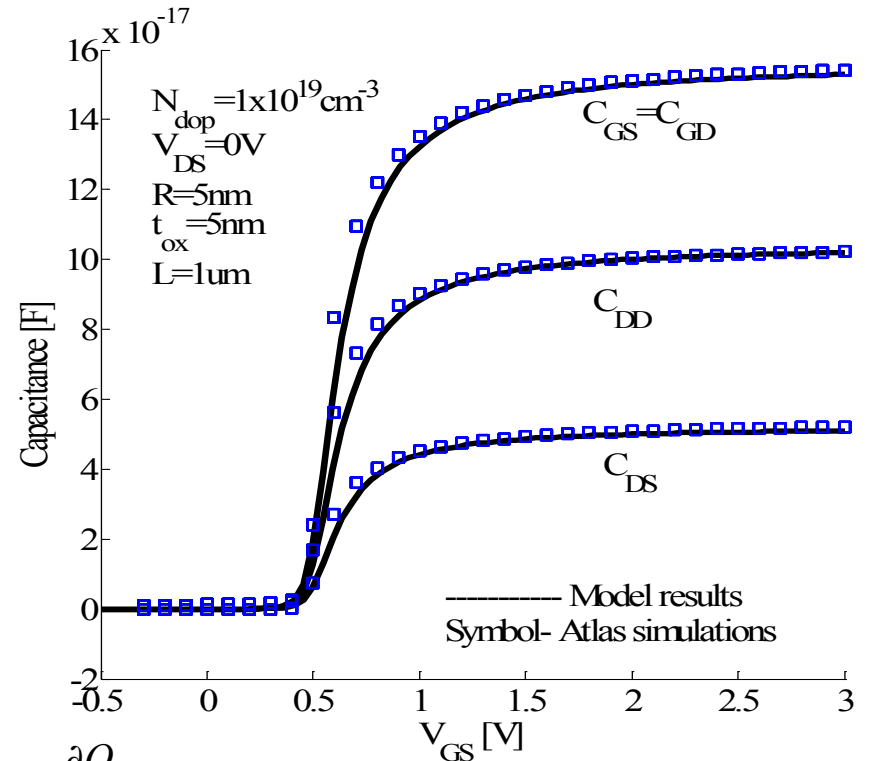
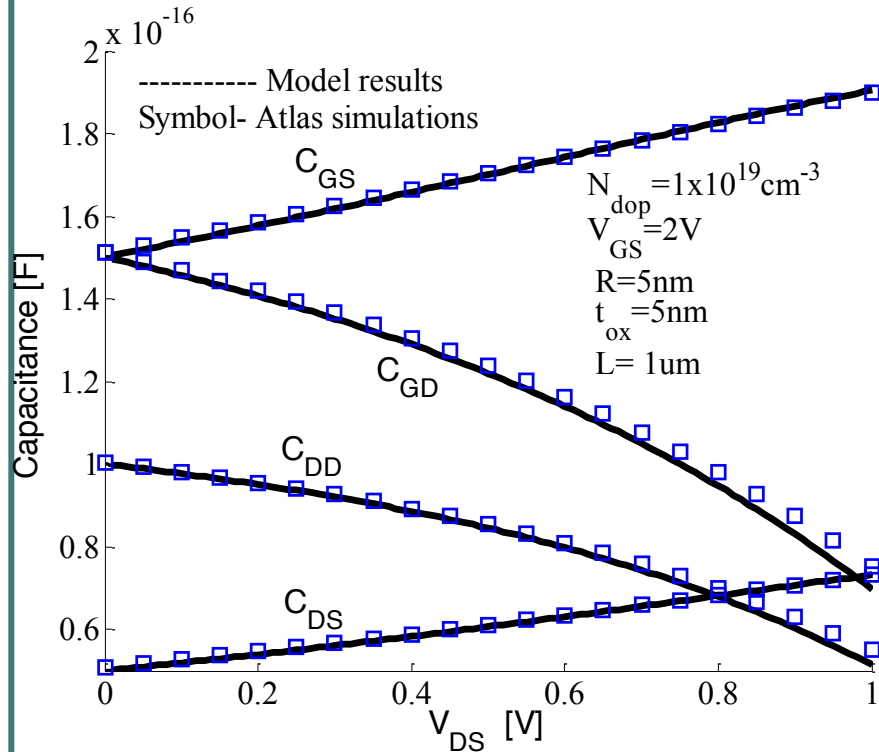
# ATLAS simulations vs MODEL



By computing four out of the nine possible intrinsic capacitances we can, afterwards, calculate the other five



# ATLAS simulations vs MODEL

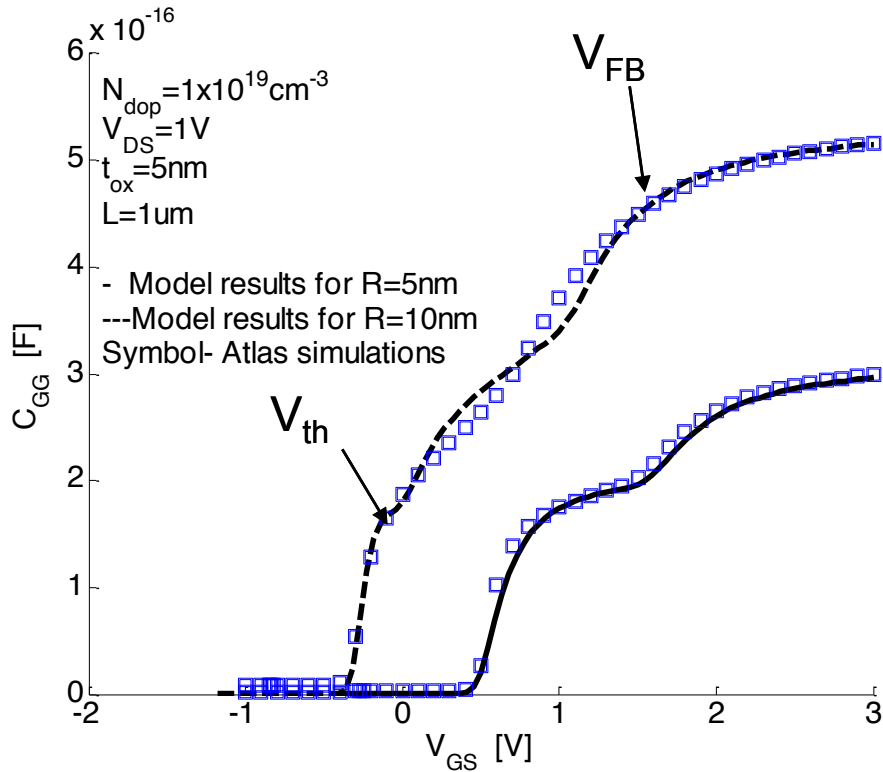


$$C_{gg} = -2\pi RL \frac{\partial Q_d}{\partial V_d}$$

**O/O Instability**

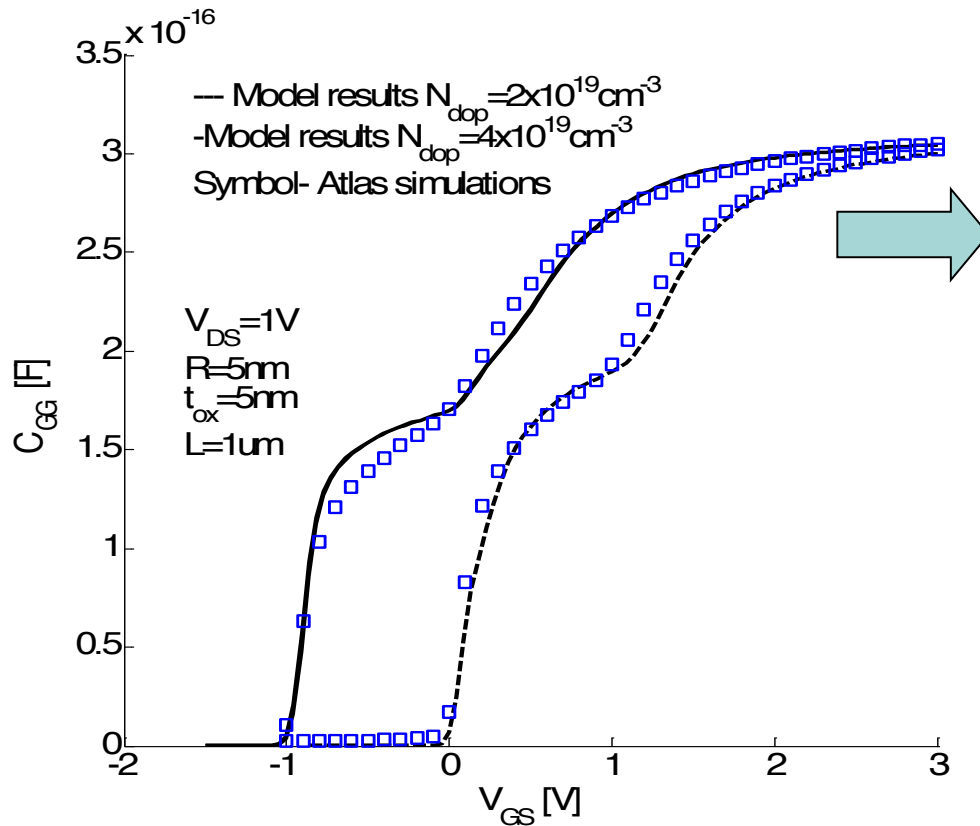
$$C_{gg} = 2C_{GS} = 2C_{GD} = 2C_{SG} = 2C_{DG} = 3C_{SS} = -3C_{DD} = -6C_{SD} = -6C_{DS}$$

# $C_{GG} = C_{GS} + C_{GD}$ for $R=5\text{nm}$ and $R=10\text{nm}$



- $R=5\text{nm}$ —no ‘distorsions’
- similar capacitance curve as for inversion transistors
- $R=10\text{nm}$  – see ‘distorsions’

# $C_{GG}$ for different $N_{dop}$



As  $V_{th}$  becomes more negative, the transition part becomes more visible

Which is the optimum Si thickness versus doping combination???

# Advantages of our model

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- Explicit and analytic
- Very simple and easy to implement
- Reproduces well the two different conduction modes: accumulation & depletion
- Good agreement with 3D numerical simulations
- Some limitations, but not regarding a real device

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**Thank you for your attention!**